



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yosuke SHIRATA

Group Art Unit: 2851

Serial No.: 09/684,898

Examiner: NGUYEN, H.

Filed: October 10, 2000

Confirmation No. 221

For: **LITHOGRAPHY SYSTEM AND METHOD**

REQUEST FOR RECONSIDERATION

Commissioner for Patents
Washington, D.C. 20231

Date: December 16, 2002

Sir:

In response to the Office Action dated November 19, 2002, it is requested to reconsider the rejection.

#9
12/20/02
APR
RECEIVED
TECHNOLOGY CENTER 2800
DEC 17 2002